

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Goro NAKATANI et al.)	Confirmation No.: 4701
)	
Application No.: 10/043,276)	Group Art Unit: 2811
)	
Filed: January 14, 2002)	Examiner: Junghwa M. Im
)	
For: SEMICONDUCTOR DEVICE AND)	Mail Stop RCE
METHOD FOR MANUFACTURING)	
THE SAME)	

Mail Stop RCE

Commissioner of Patents
U.S. Patent and Trademark Office
Alexandria, VA 22314

Sir:

AMENDMENT WITH RCE

Prior to the continued examination of the above-identified application, please amend the application as follows: